METHOD OF DOUBLE-SIDED ETCHING

Appl. No.

10/711,883

Confirmation No. 5882

Applicant

Chen-Hsiung Yang

Filed

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Examiner

CHEN, KIN CHAN

Docket No.

TMIP0003USA0

Customer No.

27765

Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

AMENDMENT

In response to the Office action of July 11, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 5 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

10 Remarks/Arguments begin on page 6 of this paper.

An **Appendix** including amended drawing figures is attached following page 8 of this paper.